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Title: Pockels effect based fully integrated, strained silicon electro-optic modulator

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Abstract: We demonstrate for the first time a fully integrated electro-optic modulator based on locally strained silicon rib-waveguides. By depositing a Si₃N₄ strain layer directly on top of the silicon waveguide the silicon crystal is asymmetrically distorted. Thus its inversion symmetry is broken and a linear electro-optic effect is induced. Electro-optic characterization yields a record high value $\chi^{(2)}(yyz) = 122$ pm/V for the second-order susceptibility of the strained silicon waveguide and a strict linear dependence between the applied modulation voltage $V(\text{mod})$ and the resulting effective index change $\Delta n(\text{eff})$. Spatially resolved micro-Raman and terahertz (THz) difference frequency generation (DFG) experiments provide in-depth insight into the origin of the electro-optic effect by correlating the local strain distribution with the observed second-order optical activity.